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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Susumu HORITA, et al.**

Serial Number: **Not Yet Assigned**  
(§371 of International Application PCT/JP03/11988)

Filed: **March 18, 2005**

For: **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE AND  
SUBSTRATE PROCESSING APPARATUS**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 18, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

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INFORMATION DISCLOSURE STATEMENT  PTO-1449	Atty. Docket No. 050169	Serial No. New Application
Applicant(s): Susumu HORITA, et al.		
	Filing Date: March 18, 2005	Group Art Unit: Not Yet Assigned

#### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	5,693,578	T. Nakanishi, et al.	12/02/97		
_____	AB					
_____	AC					
_____	AD					

#### FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AE	1-239933	Japan	Cited in the International Search Report
_____	AF	5-29307	Japan	Cited in the International Search Report
_____	AG			
_____	AH			
_____	AI			

#### OTHER DOCUMENTS

_____	AJ	
_____	AK	
Examiner _____		Date Considered _____